



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 17, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

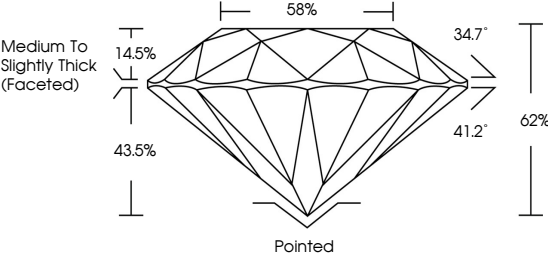
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG729575420

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



Medium To Slightly Thick (Faceted)

58%

34.7°

41.2°

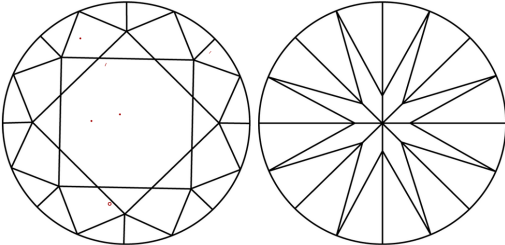
62%

43.5%

14.5%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

Sample Image Used



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LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.53 - 6.57 X 4.06 MM

1.07 CARAT

D

VVS 2

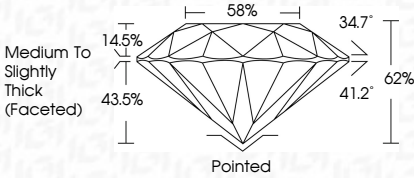
IDEAL

EXCELLENT

EXCELLENT

NONE

 LG729575420



Medium To Slightly Thick (Faceted)

58%

34.7°

41.2°

62%

43.5%

14.5%

Pointed



IGI



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September 17, 2025

IGI Report No LG729575420

ROUND BRILLIANT

6.53 - 6.57 X 4.06 MM

Color Grade

Clarity Grade

Depth

Table

Grade

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscriptions(s)

1.07 CARAT

D

VVS 2

IDEAL

62%

88%

EXCELLENT

EXCELLENT

NONE

 LG729575420

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